

03/10/2009

4319.70023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yoichiro Ohta	)
		)
Serial No.:	10/796,344	)
		)
Conf. No.:	1978	)
		)
Filed:	3/9/2004	)
		)
For:	VACUUM PROCESSING	)
	APPARATUS	)
		)
Art Unit:	1792	)
		)
Examiner:	Lund, Jeffrie Robert	)

**AMENDMENT F**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed December 23, 2008, please  
amend the application as follows: